

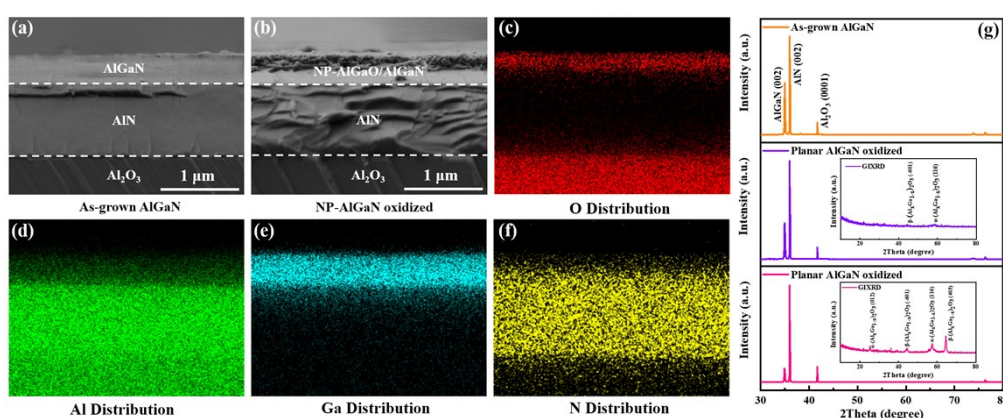
# High-Performance Shortwave Deep-UV Response-Enhanced Photodetector Based on Nanoporous AlGaO/AlGaN with Efficient Light-Harvesting

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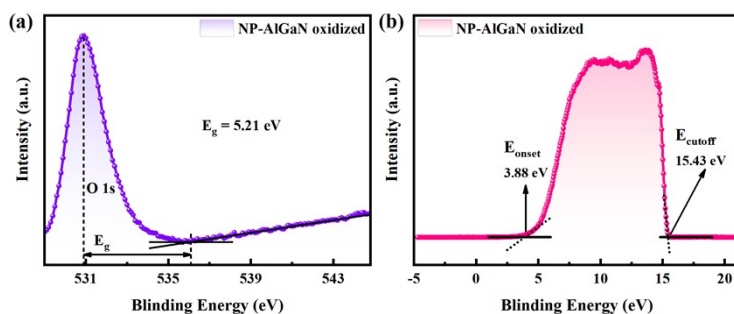
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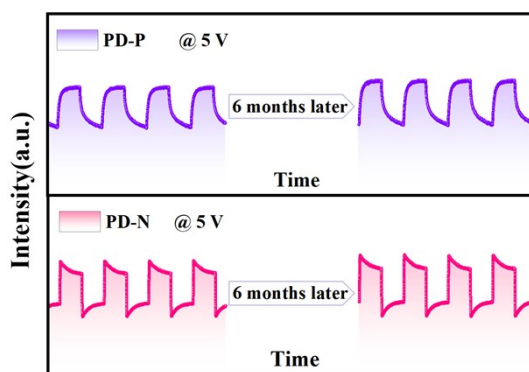
**Fig. S1.** (a) Cross-sectional morphology of the As-grown AlGaN. (b) Cross-sectional morphology, (c) O element, (d) Al element, (e) Ga element and (f) N element distribution of the NP-AlGaN oxidized. (g) XRD  $\omega$ - $2\theta$  patterns for as-grown AlGaN. XRD  $\omega$ - $2\theta$  patterns with the inset of the grazing incident angle XRD patterns for the planar AlGaN oxidized and the NP-AlGaN oxidized.



**Fig. S2.** (a) O 1s energy loss spectrum for determining bandgap and (b) UPS spectrum of the NP-AlGaN after oxidation.

The bandgap of the top AlGaO layer in the oxidized NP-AlGaN was extracted by the energy loss spectra of O 1s as illustrated in Fig. S2a. The maximum energy of O 1s peak was set to zero loss energy, followed by the linearly extrapolated the

maximum negative slope of the spectral line to the background level. Then the energy difference between the peak and the intersection provides the bandgap value, demonstrating it of 5.21 eV. In addition, the UPS spectra of the top AlGaO layer in the oxidized NP-AlGaN have been investigated with a monochromatic He I light source (21.22 eV), as shown in Fig. S2b. Similarly, the energy separation ( $E_{\text{onset}}$ ) between the Fermi level and the top of valence-band energy was extracted to be 3.88 eV, and the binding energy of the cutoff edge ( $E_{\text{cutoff}}$ ) was extracted to be 15.43 eV, which were utilized to deduce the height of the valence band.



**Figure S3.** Time-dependent photoresponse curves of PD-P and PD-N measured at as-prepared and after 6 months of storage in the ambient air.

**Table S1.** Comparison of the performance parameters of the reported UV PDs based on various nanostructures and planar structures

Structures	Responsivity (A/W)	Detectivity (Jones)	Response time ( $\tau_r/\tau_d$ )	$I_{\text{Photo-P}\lambda}$ exponent $\alpha$	PDCR	GBP	Ref.
AlGaN nanowires	0.049 (0 V @254 nm)	-	83/19 ms	< 1	-	2.53	47 <sup>1</sup>
AlGaN APD	0.13 (20 V @276 nm)	$1.4 \times 10^{14}$	-	-	$\sim 1 \times 10^4$	> 1560	48 <sup>2</sup>
AlGaO nanowires	0.726 (5 V @242 nm)	-	-	-	$1 \times 10^3$	-	49 <sup>3</sup>
$\beta$ -Ga <sub>2</sub> O <sub>3</sub> film	26.1 (10 V @255 nm)	$1.2 \times 10^{13}$	48/18 ms	-	$10^4$	145	50 <sup>4</sup>
$\beta$ -Ga <sub>2</sub> O <sub>3</sub> nanosheets	3.3 (10 V @254 nm)	$4.0 \times 10^{12}$	30/60 ms	1.8	4.5	55	51 <sup>5</sup>
$\alpha$ -Ga <sub>2</sub> O <sub>3</sub> nanorod	1.73 (1 V @254 nm)	$2.53 \times 10^{12}$	0.678/0.178 s	0.78	$3.79 \times 10^4$	9.7	52 <sup>6</sup>
NP- Ga <sub>2</sub> O <sub>3</sub> /GaN	0.44 (0 V @254 nm)	$2.7 \times 10^{11}$	0.12/0.44 s	-	272	3.7	53 <sup>7</sup>
$\beta$ -Ga <sub>2</sub> O <sub>3</sub> /NP-GaN	$4.5 \times 10^5$ (10 V @360 nm)	$8.27 \times 10^{15}$	1.09/0.79 s	-	$\sim 10^2$	$4.1 \times 10^5$	54 <sup>8</sup>
Mesoporous GaN	$\sim 1.4 \times 10^4$ (0.8 V @352 nm)	$5.3 \times 10^{14}$	> 20/60 s	0.2	-	< 700	55 <sup>9</sup>
NP-GaN nanocolumn/ nanowall network	7.25-27.72 (2V)	$1.15\text{-}1.96 \times 10^{11}$	> 10 s	-	$\sim 1.5$	-	56 <sup>10</sup>
NP-AlGaO/AlGaN	1.54 (5V @245 nm)	$1.5 \times 10^{13}$	6/7 $\mu$ s	0.98	$6.8 \times 10^4$	$2.6 \times 10^5$	This work

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